

ZAN



Docket No.: 8734.254.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yun Ho JUNG

Customer No.: 30827

Application No.: 10/705,891

Confirmation No.: 6104

Filed: November 13, 2003

Art Unit: 1756

For: MASK FOR LASER IRRADIATION AND  
APPARATUS FOR LASER  
CRYSTALLIZATION USING THE SAME

Examiner: Stephen D. Rosasco

**MS Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated July 28, 2006, please amend the above-identified Patent Application as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.